

FORM 1449* THIRTY-FOURTH SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT IN AN APPLICATION (Use several sheets if necessary)	Docket Number: 60001.0050US11/MS149368.2	Application Number: 09/841,266
	Applicant: Jeff Reynar	
	Filing Date: April 24, 2001	Group Art Unit: 2176

U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
/CN/	6,556,972	04.2003	Bakis et al.	704	277	
/CN/	6,208,338 B1	03.2001	Fischer et al.	715	705	
/CN/	6,297,822 B1	10.2001	Feldman	715	705	
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	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)		
/CN/		U.S. Office Action dated February 8, 2008 cited in U.S. Application No. 10/141,712
/CN/		U.S. Office Action dated February 15, 2008 cited in U.S. Application No. 10/731,899
/CN/		U.S. Final Office Action dated February 20, 2008 cited in U.S. Application No. 10/154,630
/CN/		Singapore Examination Report (conducted by Austrian Patent Office) dated January 25, 2008 in SG Application No. 200500214-2
/CN/		Chinese Official Action dated January 4, 2008 cited in Chinese Application No. 200510009487.0



EXAMINER /Chau Nguyen/	DATE CONSIDERED 04/29/2008
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form for next communication to the Applicant.	